

Title (en)

METHOD FOR PRODUCING AN INTEGRATED PIN DIODE AND CORRESPONDING CIRCUIT

Title (de)

VERFAHREN ZUM HERSTELLEN EINER INTEGRIERTEN PIN-DIODE UND ZUGEHÖRIGE SCHALTUNGSANORDNUNG

Title (fr)

PROCEDE DE PRODUCTION D'UNE DIODE PIN INTEGREE ET CIRCUIT ASSOCIE

Publication

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Application

**EP 03794789 A 20030814**

Priority

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Abstract (en)

[origin: WO2004025739A2] The invention relates to, inter alia, a method for producing an integrated PIN photodiode comprising a buried region (20) and a connection region (32) which leads towards the buried region (20). Said method enables the PIN photodiode (14) to be integrated in a simple manner. Furthermore, process steps for producing said PIN diode can also be carried out for the production of screening troughs (22, 56).

IPC 1-7

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IPC 8 full level

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CPC (source: EP US)

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Citation (search report)

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